

Atty Docket
033082W001

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01/19/99
JCS98 U.S. PTO

PATENT
CS26 U.S. PTO
09/233073
01/19/99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kenichi Nanbu
Serial No. : to be assigned
Filed : January 19, 1999
For : METHOD OF ETCHING

LETTER ACCOMPANYING APPLICATION FILED
UNDER 37 CFR 1.52(d)

Hon. Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

The subject application is being filed in a foreign language (Japanese) under 37 CFR 1.52(d). The enclosed Japanese language application includes 12 pages of written disclosure and 9 sheets with Figures 1 through 9.

This application is based on Japanese Patent Appln. No. 89421/1998 filed on March 18, 1998 and priority will be claimed.

A verified English language translation will be filed in due course.

Attached is an unsigned declaration.

The filing fee for the application will be filed at a later date.

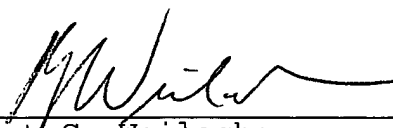
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Respectfully submitted,

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